

Application/Control No.	Applicant(s)/Patent under Reexamination	
08/990,096	PICHER-DEMPSEY, HEIDI	
Examiner	Art Unit	
Hanh Nguyen	2616	

SEARCHED					
Class	Subclass	Date	Examiner		
709	223	5/10/2007	ни		
	224				
	203				
	218				
	219				
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	225				
370	351				
370	352				
370	230				
	230.1				
	231				
	468				
370	395.41				

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
370	468	5/10/2007	HN			
	352					
709	2254					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East	5/10/2007	HN		
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